# High Temperature Microhardness Tester

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**ABSTRACT (Maximum 200 words)**

Funds were obtained through the Defense University Research Instrumentation Program (DURIP) for the purchase of a hardness machine capable of indenting at elevated temperatures. The instrument selected was the Nikon High Temperature Microhardness Tester, Model QM. This apparatus has an operating range from room temperature to 1600°C, with loads varying from 0.5 to 10N. The instrument is now installed and fully operational. It represents a very valuable and convenient method of evaluating the indentation properties of ceramics at elevated temperatures. Although presently at a preliminary stage, the indentation creep studies look particularly promising as a means of studying the high temperature mechanical behavior.
High Temperature Microhardness Tester
Grant # AFOSR-89-0106 (DURIP)

Final Report
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Introduction
Funds were obtained through the Defense University Research Instrumentation Program (DURIP) for the purchase of a hardness machine capable of indenting at elevated temperatures. The instrument selected was the Nikon High Temperature Microhardness Tester, Model QM. This apparatus has an operating range from room temperature to 1600 °C, with loads varying from 0.5 to 10 N. An automatic timer enables variation of the load dwell time from 0.1 to 1000s. However if longer indentation times are required, e.g. for indentation creep studies, the time can be controlled manually. The Nikon QM was chosen in preference to other commercially available machines because it can attain significantly higher test temperatures. This was of particular importance, since the rationale for obtaining this apparatus was the need for evaluating the high temperature mechanical properties of ceramic specimens. Furthermore, the Nikon QM was the only instrument in which the indenter and specimen are separately heated, thus ensuring greater temperature control during the indentation process.
Budget

The amount budgeted for the instrument in the original proposal was $109,032.00 (see Appendix 1). By negotiating the purchase of a demonstration model, Lehigh was able to persuade Nikon to include a temperature control unit (costing $6,879.00) for the original price. In addition, Nikon agreed to give Lehigh a 5% educational discount ($5,479.00). Of the remaining cost, $88,478.00 was provided by the AFOSR (through DURIP), and the balance was provided as cost sharing by Lehigh University.

Installation

The Nikon QM was installed in February 1989, and is located in the Dept. of Materials Science & Engineering, in a laboratory dedicated to that apparatus. A computer controlled log-on system has been installed. This provides detailed records on instrument use time, names of operators etc., and also prevents unauthorized use by untrained persons.

Research

Examples of the types of studies in which the Nikon QM has been utilized are discussed briefly in the following. In terms of the AFOSR project on "Strength and Toughness of Tailored Ceramic Microstructures", the hot hardness tester has been used to evaluate i) the variation of hardness with temperature for a range of $x\text{Al}_2\text{O}_3(1-x)\text{c-ZrO}_2$ composites, and ii) indentation creep in $\text{Al}_2\text{O}_3.50 \text{ vol}\% \text{ZrO}_2$ (AZ50). The results of these tests are
depicted in Figures 1 and 2 respectively. Figure 1 shows that as the c-ZrO$_2$ content increases, the hardness of the composite (at any given temperature) decreases. It is interesting, however, that all of the hardness vs. temperature curves show a discontinuity in the slope at $\sim 500\,^\circ C$, indicating a change in the deformation mechanism. Figure 2 shows (somewhat intriguingly) that although single phase alumina is harder than single phase cubic zirconia, the duplex AZ50 is harder at 1200 $^\circ C$ for all indentation times. Work is currently underway to determine the underlying physical mechanisms for this behavior.

Data taken using the Nikon QM in related studies are shown in Figures 3 and 4. Figure 3 shows indentation creep results for polycrystalline cubic zirconia. These results, together with indentation creep data for Al$_2$O$_3$ will be compared with that of AZ50 to gain an estimate of the relative creep resistance of the duplex material. Figure 4 shows a comparison of the high temperature hardness behavior of anorthite (CaO.Al$_2$O$_3$.2SiO$_2$) and alumina. It can be seen that although at room temperature the hardness of anorthite is significantly lower than that of alumina, at around 1000 $^\circ C$, the hardness values are very much comparable. This information proved to be very valuable in interpreting the mechanical properties of a two-phase alumina in which the intergranular glassy phase had been crystallized to form anorthite. Finally, Figure 5 is an example of work taken from a project related to electronic packaging materials, and shows the temperature dependence of hardness of AlN.
Figure 1

Graphs of Vickers hardness vs. temperature for a series of $x \text{Al}_2\text{O}_3 \cdot (1-x) \text{c-ZrO}_2$ composites ($x = 0, .05, .25, .5$ and $.75$).

Courtesy J.D. French
Figure 2

Indentation creep curves at 1200°C for AZ50 (filled symbols) and Al₂O₃ (open symbols)

Courtesy J.D. French
Creep Studies for Polycrystalline Zirconia @ 26 C, 500 C and 1000 C

Figure 3

Indentation creep curves for c-ZrO$_2$ obtained at 26°C, 500°C and 1000°C.

Courtesy J. Stanescu
Figure 4

Graphs of Vickers hardness vs. temperature for anorthite and alumina.

Courtesy N.P. Padture
Fig. 1  Hardness of Translucent AlN vs. temperature

Graphs of Vickers hardness vs. temperature for AlN. Courtesy T. Liu and M.R. Notis
The list of projects at Lehigh which currently benefit from the apparatus is summarized in Table 1. In addition to usage by Lehigh faculty and students, there have been several external users of the facility, and these are listed in Table II.

Summary

The Nikon QM high temperature microhardness tester is now installed and fully operational. It represents a very valuable and convenient method of evaluating the indentation properties of ceramics at elevated temperatures. Although presently at a preliminary stage, the indentation creep studies look particularly promising as a means of studying the high temperature mechanical behavior. As research progresses, it is intended to combine this data with detailed microstructural examination of the indentation sites. It is envisaged that this will yield much needed information on the influence of temperature on the deformation mechanisms in ceramics.
<table>
<thead>
<tr>
<th>Contract</th>
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<th>Principal Investigators</th>
<th>Current Year Funding</th>
<th>Continuing Funding</th>
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<td>AFOSR #870396</td>
<td>Strength and Toughness of Tailored Ceramic Micro-Structures</td>
<td>M.P. Harmer, H.M. Chan, G.A. Miller</td>
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<td>Through 10/90</td>
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<tr>
<td>DMR-8920844</td>
<td>Influence of Temperature on Indentation-Induced Flow Nucleation Processes in Ceramic Materials</td>
<td>H.M. Chan</td>
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<td>Coors</td>
<td>R-Curve Behavior of Glass Ceramics</td>
<td>H.M. Chan, B.R. Lawn, M.J. Readey</td>
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<td>DE-FG02-86ER45256</td>
<td>Grain Boundary Diffusion in Oriented Ni$_3$Al Bicrystals Containing Boron</td>
<td>Y.T. Chou</td>
<td>$89,500</td>
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<td>Analytical Electron Microscopy Studies of Interfaces and Phase Transformations in Zirconia Ceramic Systems</td>
<td>M.R. Notis</td>
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<td>Electronic Device Packaging Technology: Sub Program in New Ceramic Substrate Materials</td>
<td>M.R. Notis (R.J. Jaccodine)</td>
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<td>Quantitative Microanalysis of Li and Be Intermetallics</td>
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### TABLE II

External Users of High Temperature Microhardness Facility

1. **Ms. S.W. Wang and Dr. A. Majidi**  
   Dept. Mechanical Engineering  
   University of Delaware  
   Project Title: "Processing and Characterization of Continuous Fiber Reinforced Glass and Glass-Ceramic Matrix Composites"  
   Sponsored by AFOSR

2. **Dr. C.D. Graham**  
   Dept. Materials Science and Engineering  
   University of Pennsylvania  
   Project Title: "Development of Texture by Warm Deformation of Fe-Nd-B Permanent Magnets"  
   Sponsored by NSF

3. **SCM Metal Products, Inc.**  
   11000 Cedar Avenue Suite 100  
   Cleveland, OH 44106

4. **Dr. S. Bose**  
   United Technologies  
   Pratt and Whitney  
   E. Hartford, CT 06108
APPENDIX I

BUDGET

Nikon High Temperature Microhardness Tester Model QM $109,032.00

Basic Unit consisting of
- Indenter loading and vacuum control unit
- Heating control unit
- Power control unit
- Console desk equipped with micrometer
- Lamp housing
- Rotary oil pump

Supplied with:
- 2 high temperature furnaces
- 2 furnaces for indenter
- 2 specimen holder (cylindrical)
- 2 specimen holder (block format)
- 2 diamond micro-vickers indenter
- 2 sapphire micro-vickers indenter
- 2 halogen lamps (12V/100W)

Accessories
- Diamond knoop indenter $539.00

TOTAL $109,571.00

Educational Discount (5%) $5,479.00

Less cost sharing by Lehigh University (15%) $15,614.00

Amount Requested from DoD $88,478.00

Contact Person: Mr. Matthew Smith
Nikon Inc.
(516) 222-0200